



INTERNATIONAL ATOMIC ENERGY AGENCY  
UNITED NATIONS EDUCATIONAL, SCIENTIFIC AND CULTURAL ORGANIZATION  
**INTERNATIONAL CENTRE FOR THEORETICAL PHYSICS**  
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UNITED NATIONS INDUSTRIAL DEVELOPMENT ORGANIZATION



**INTERNATIONAL CENTRE FOR SCIENCE AND HIGH TECHNOLOGY**

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**Second Training College on Physics and Technology  
of Lasers and Optical Fibres**

21 January - 15 February 1991

*Optical Amplifiers*

James Wilkinson  
Optoelectronics Research Centre  
The University  
Southampton, U.K.

**OUTLINE**

- o **Advantages of optical amplification**
- o **Applications of optical amplifiers**
- o **Major types of optical amplifier**
- o **Noise in optical amplifiers**
- o **Principles of optical amplification**
- o **Semiconductor optical amplifier**
- o **Erbium-doped fibre amplifier**
- o **Raman optical fibre amplifier**
- o **System performance**

## ADVANTAGES OF OPTICAL AMPLIFICATION

- o **Simplicity**
- o **Low cost**
- o **Reliability**
  
- o **Transparency**
- o **Flexible bit-rate & modulation format**
- o **Direct or coherent detection systems**
- o **Upgrade number of channels**
  
- o **Wide optical bandwidth**
- o **Multichannel operation**
- o **Very high data rates**

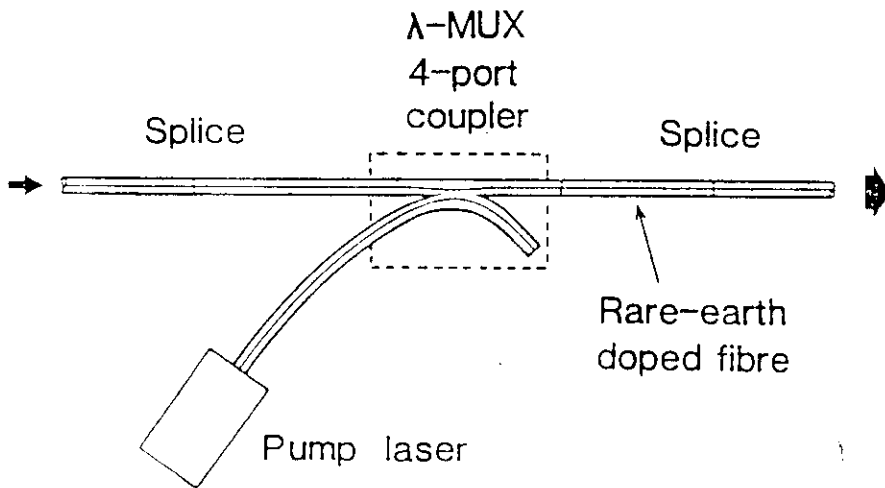
## APPLICATIONS OF OPTICAL AMPLIFIERS

- o **Line amplifiers**
- o **Reduce number of regenerators**
- o **Allow transparent transmission**
  
- o **Preamplifiers**
- o **Improve SNR in high bit-rate direct detection systems**
  
- o **Power amplifiers**
- o **Boost signals to compensate branching losses in multi-terminal networks**

## MAJOR TYPES OF OPTICAL AMPLIFIER

- o Erbium-doped optical fibre amplifier (EDFA)
- o Semiconductor laser optical amplifiers (SCLA)
- o Raman optical fibre amplifier (RFA)

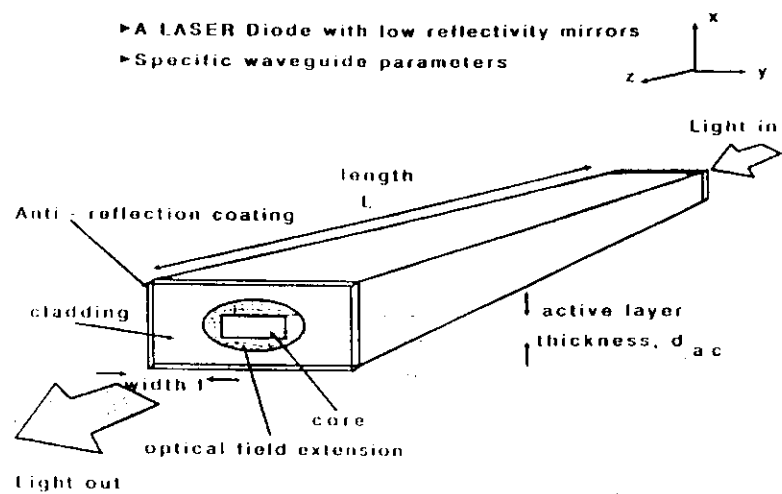
## BASIC ERBIUM AMPLIFIER CONFIGURATION



## ADVANTAGES OF ERBIUM DOPED FIBRE AMPLIFIERS

- o Low fibre coupling loss
  - High fibre-fibre gain ( >40dB )
  - Low feedback & passband ripple
  - Good noise figure ( ~3dB )
- o Polarisation insensitive
  - No polarisation controller
- o Large energy storage
  - Low interchannel crosstalk
  - Low pump noise feedthrough
  - Operates deep in saturation
- o High saturation o/p power ( >10 dBm )
- o Gain passband insensitive to temperature

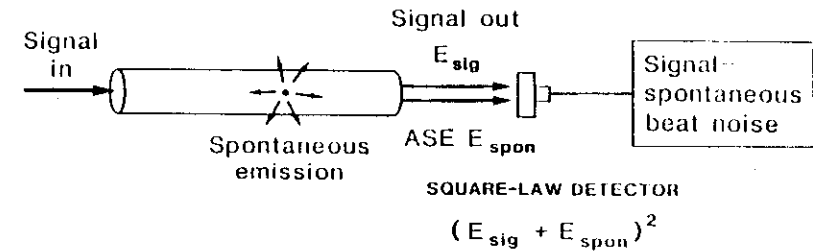
## BASIC STRUCTURE OF THE SEMICONDUCTOR AMPLIFIER



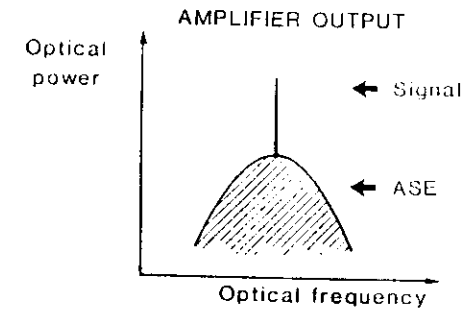
## ADVANTAGES OF SEMICONDUCTOR OPTICAL AMPLIFIERS

- o Direct injection pumping
- o Not restricted to 1500nm wavelength band
- o Integrable into complex switchable arrays
- o Compatible with optoelectronic integration

## NOISE IN OPTICAL AMPLIFIERS



## NOISE MECHANISMS



- Signal heterodynes with ASE → signal-spontaneous beat noise
- ASE heterodynes with itself → spontaneous-spontaneous beat noise
- Amplified signal shot noise (negligible)

### Noise in Optical Amplifiers

Assuming a detector of unit quantum efficiency, the noise power spectral density due to amplified signal and ASE is :

$$\langle i^2 \rangle = \frac{2e^2}{h\nu} (A + B + C)$$

$$A = P_s + P_{SP} \quad \text{--- shot noise term}$$

$$B = 2\mu P_s (G - 1) \quad \text{--- signal/spontaneous beat term}$$

$$C = 2\Delta\nu \cdot h\nu [\mu(G - 1)]^2 \quad \text{--- spont./spont. beat term}$$

$n_{SP}$  = Inversion factor

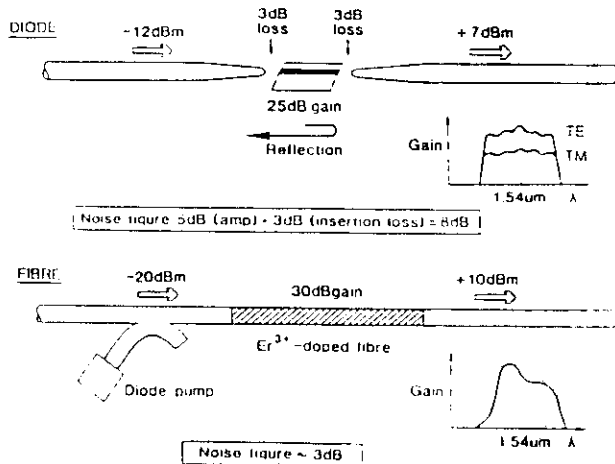
$\Delta\nu$  is the ASE spectral width,  $G$  is the amplifier gain,  $P_s$  and  $P_{SP}$  are the signal and spontaneous optical powers at the output.

For most applications  $B$  dominates and Noise Figure is:

$$NF = \frac{\text{Input sig./noise power ratio}}{\text{Output sig./noise power ratio}} = \left[ \frac{P_{in}}{P_{out}} \right]^2 \frac{\text{Noise}_{in}}{\text{Noise}_{out}} = \frac{1}{G^2} \cdot \frac{B}{P_s/G} \approx 2\mu$$

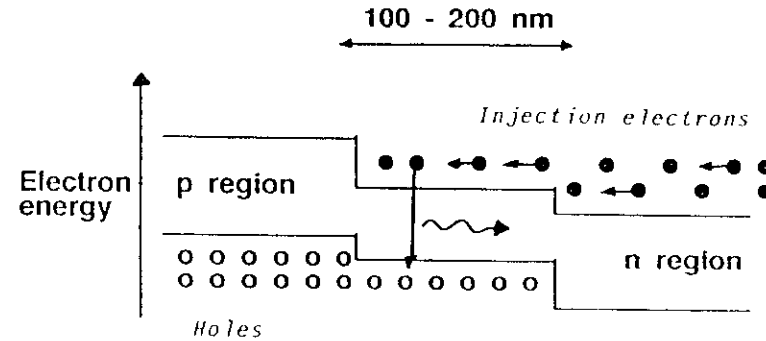
For a fully inverted amplifier  $\mu = 1$  and  $NF = 3\text{dB}$

### COMPARISON OF DIODE AND FIBRE AMPLIFIERS



### PRINCIPLES OF SEMICONDUCTOR OPTICAL AMPLIFIERS

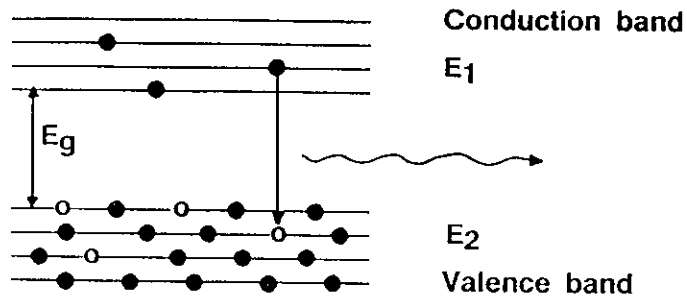
#### PN Double Heterostructure



Narrow band-gap material with high refractive index inserted between n & p regions, forming two heterojunctions.

- High injection efficiency
- Carriers confined to thin active region
- Photons confined to thin active region
- Outer regions transparent to radiation
- Lattice mismatch leads to nonradiative recombination
- Internal quantum efficiency 60 - 80 %

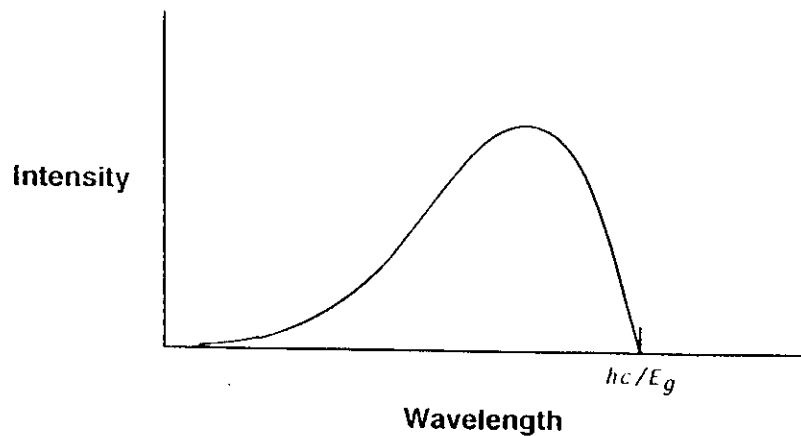
## Spontaneous Emission



Emitted photon energy,  $E_{ph} = E_1 - E_2$

Planck's law gives  $\lambda = hc / E_{ph}$

Light is emitted with arbitrary phase and direction



Spontaneous Emission Spectrum

## Spectral Linewidth

Analysis of the carrier energies in the valence and conduction bands shows that the spectral width (HPFW) of spontaneous emission is given approximately by:

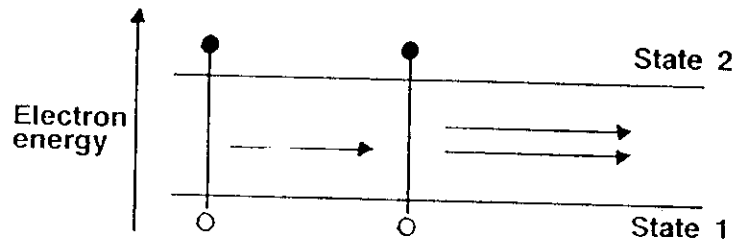
$$\frac{\Delta\lambda}{\lambda} = 2kT / E_{ph}$$

This leads to the following approximate values for the linewidth of LED's:

Wavelength (nm)	Linewidth (nm)
850	30
1300	70
1550	100

These linewidths are low estimates in practice, due to high doping levels, lattice interactions & high-temperature

## Stimulated Emission



Photon stimulates recombination creating a further photon

- same energy
  - same phase
  - same direction
- } Coherent emission

Requires conduction electrons & holes

If there are more electrons in state 2 than in state 1:

- Stimulated emission is more probable than absorption
- The medium has gain

Stimulated emission has short carrier lifetime

## Active Layer Composition

Active layer material:

- must have band-gap smaller than substrate
- must have higher index than substrate
- must emit at desired wavelength
- must be lattice matched to substrate

$\text{Ga}_{1-x}\text{Al}_x\text{As}$  system:

- Composition ranges  $0 < x < 0.37$  for direct band-gap
- Wavelength ranges  $870\text{nm} > \lambda > 650\text{nm}$
- GaAs and AlAs have very similar lattice constants  
Hence few dangling bonds on GaAs substrate

$\text{In}_{1-x}\text{Ga}_x\text{As}_y\text{P}_{1-y}$  system on InP substrate:

- Composition ranges  $0 < x < 0.47$   
 $0 < y < 1$
- Wavelength ranges  $920\text{nm} < \lambda < 1670\text{nm}$
- Choice of  $x$  &  $y$  allows lattice matching to InP

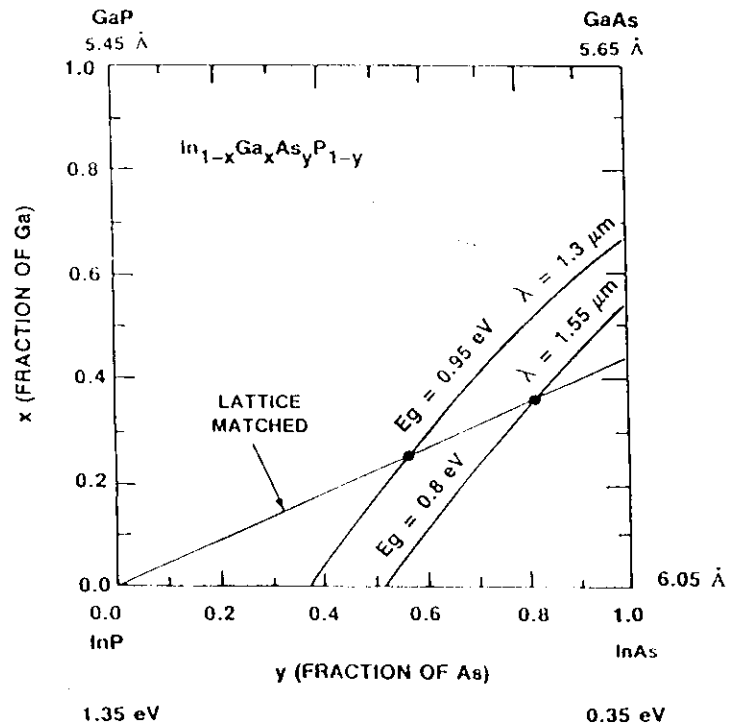
## Lattice Matching for Long-Wavelength Sources

Lattice constant must match substrate (0.587nm for InP)

Intersection of curves of - constant bandgap

- constant lattice spacing

dictates composition of quaternary compound:

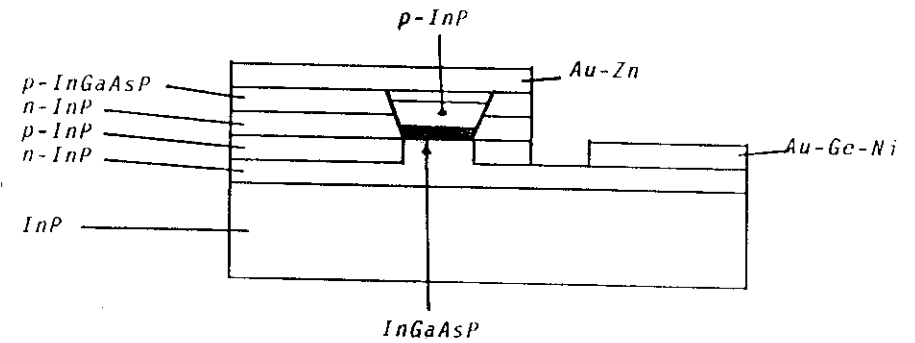


## Index-Guided or Buried Heterostructure Laser

Lateral index-guiding ensures single transverse mode:

- Linear power / current characteristic

Cavity length 250 microns; width 2.5 microns



Emission at 1500 nm

Threshold current below 40mA

T.Matsuoka et al. Electron.Lett., 17, 12, (1981)



## REQUIREMENTS FOR AMPLIFIERS

- o Low mirror reflectivity (  $<0.0001$  )

Semiconductor materials have high index

- Antireflection coatings
- Angled facets
- Buried facets

- o Weak polarisation sensitivity

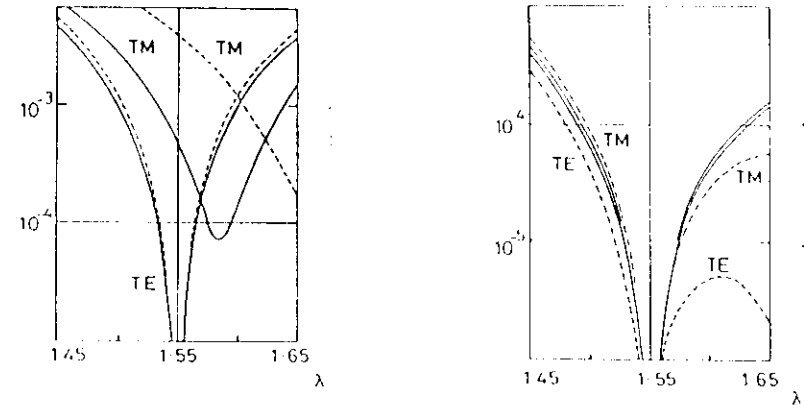
Gain in standard devices is highly polarisation-dependent

- New waveguide design
- Polarisation-insensitive configurations

## DESIGN OF ANTIREFLECTION COATINGS

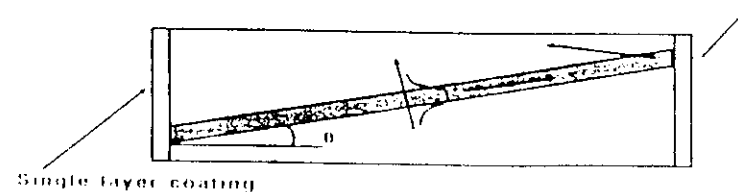
Vassallo, El.Lett, 1988

- o Double layer ar coating for low polarisation sensitivity
- o 0.5% thickness tolerance for  $R < 0.0001$



## ANGLED FACET AMPLIFIER

- o Relaxes tolerances on ar coating - single layer acceptable
- o Very good for weakly-guiding (low NA) waveguide amplifiers



## POLARISATION INSENSITIVE WAVEGUIDE DESIGN

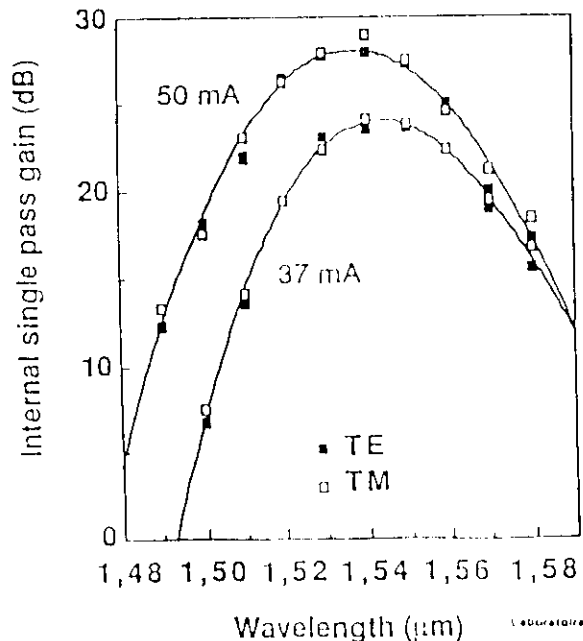
Laboratoires de Marcoussis; Centre de Recherches de la CGE

CEC RACE 1027

- o Waveguide depth = 400nm
- o Waveguide width < 1000nm
- o Amplifier length = 0.4mm

### Internal gain of optical amplifier

High gain : 28 dB at low bias current (50 mA)  
Low polarization sensitivity :  $\Delta G < 1$  dB



RACE 1027

STC jec  
Laboratoire de Marcoussis  
CHET  
Electromagnetics Institute  
University of Athens  
CS&I  
Teresio 30a  
Telefonica

## NONLINEAR OPTICAL EFFECTS IN SEMICONDUCTOR AMPLIFIERS

- o Carrier density,  $N_2$ , depends on signal intensity,  $I$ .
- o Waveguide refractive index depends upon carrier density.
  - Four-wave mixing
  - Crosstalk & intermodulation
- o Gain  $\propto [N_2 - N_1]$ 
  - Signal dependent gain

### GAIN SATURATION IN SEMICONDUCTOR AMPLIFIERS

- o Output power saturates at between 3mW & 10mW
- o Multi Quantum Well devices between 12mW & 45mW

## NOISE FIGURE OF SEMICONDUCTOR AMPLIFIER

Inversion parameter,  $\mu = N_2 / [N_2 - N_1]$

- o Ratio of spontaneous to stimulated transitions
- o Semiconductor laser amplifier:

$$\mu = [1 - \exp\{(E - \Delta f) / kT\}]^{-1}$$

where:

$E =$  Photon energy

$\Delta f =$  Quasi-Fermi level separation

$k =$  Boltzmann's constant

$T =$  Temperature

$\mu$  approximately 1.3 yielding NF of 4dB

Plus:

Contribution of input coupling loss to noise figure approx 3 dB

Contribution of semiconductor waveguide loss to noise figure 4dB

Total NF is approximately 11 dB

## GAIN AND NOISE IN A SEMICONDUCTOR AMPLIFIER

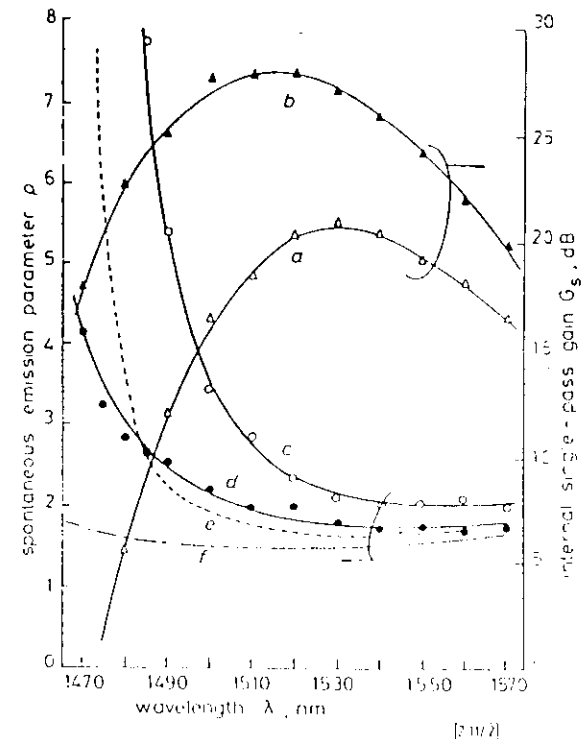
J.-C. Simon et al; Electronics Letters v25 p434, 1989.

Internal gain and noise parameter against wavelength

a,b Gain at  $2I_{th}$  &  $3I_{th}$  respectively

c,d Spontaneous emission parameter,  $u$

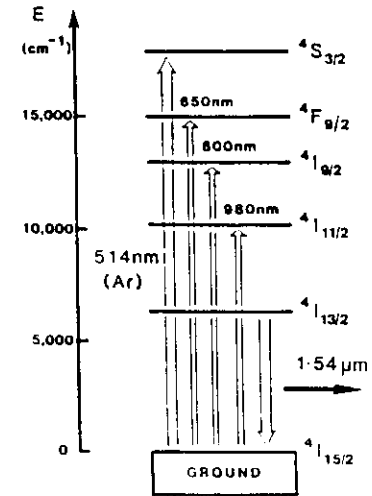
e,f Waveguide loss parameter



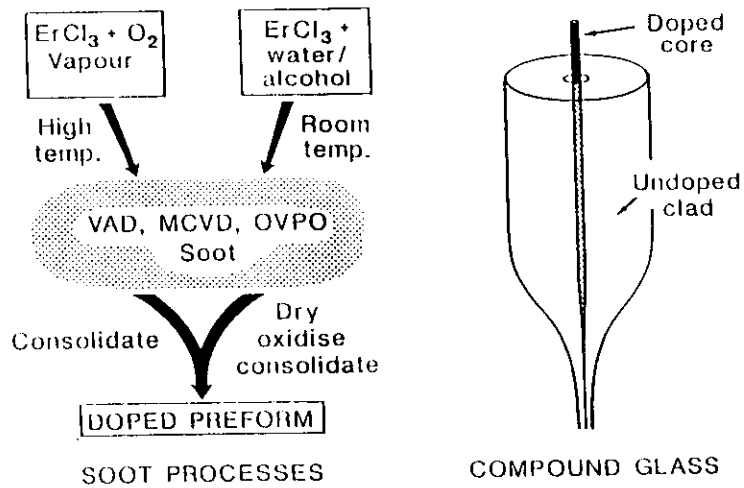
### FABRICATION OF RARE-EARTH-DOPED OPTICAL FIBRES

- MCVD vapour-phase method
  - Versatile, gives low losses
  - Low concentrations of rare-earth
- MCVD-frit vapour-phase method
  - Higher concentrations possible
- Solution-doping method
  - Very versatile
  - Applicable to MCVD, OVPO and VAD
  - High concentrations possible
  - Drying required
- Rod-in-tube
  - Compound glass e.g. phosphate

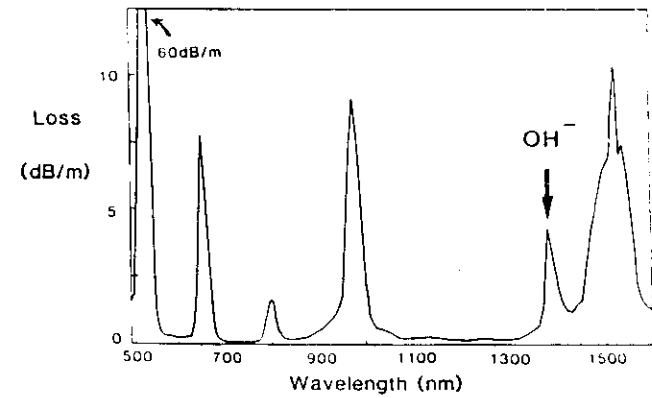
### ERBIUM ENERGY LEVELS



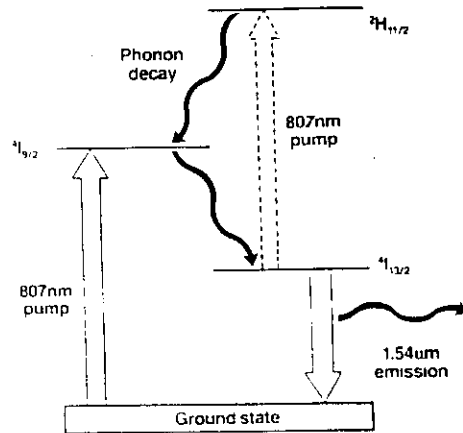
### ERBIUM-DOPED FIBRE FABRICATION



### ABSORPTION SPECTRUM OF FIBRE DOPED WITH $\text{Er}^{3+}$ IONS



### 807nm PUMP EXCITED - STATE ABSORPTION IN Er<sup>3+</sup>



SOUTHAMPTON UNIVERSITY UK

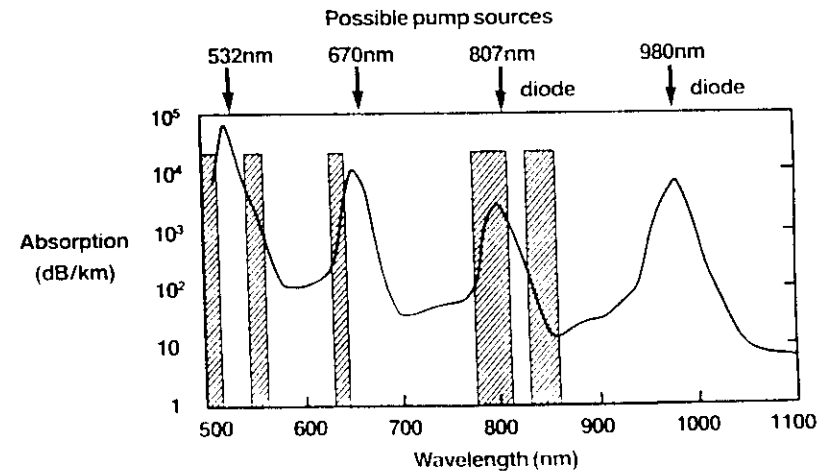
### POSSIBLE PUMP WAVELENGTHS FOR ERBIUM AMPLIFIERS

- 807nm  
Poor efficiency owing to excited-state absorption (ESA)
- 532nm  
Sources available (expensive)
- 980nm  
Gain efficient (4.0dB/mW pump)  
Diode pumps available soon
- 1047nm  
Diodes available  
Noise disadvantage

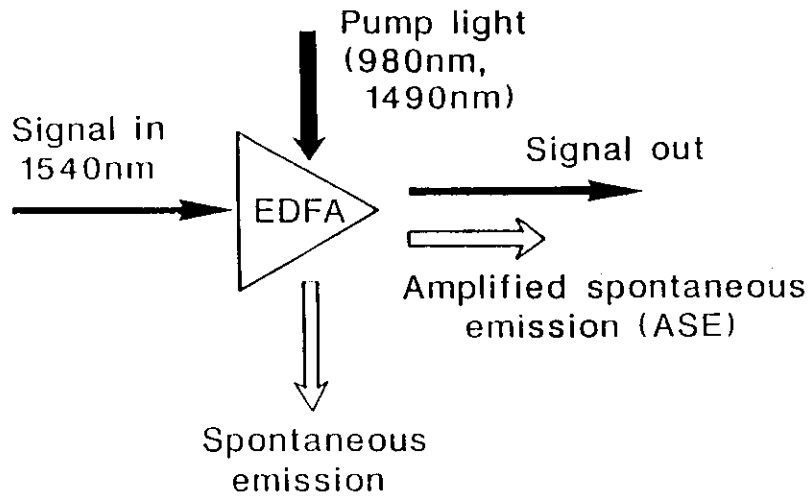
### PUMP WAVELENGTHS FOR ERBIUM FIBRE AMPLIFIERS

	980nm	1490nm
Pump/signal λMUX	Easy	Difficult
Reported pump efficiency	4.0 dB/mW	2.1 dB/mW
Spectral gain	Peaky?	Smoother
Anticipated power amplifier efficiency	Large pump/signal shift	Small shift
Noise figure	~3dB	~5dB

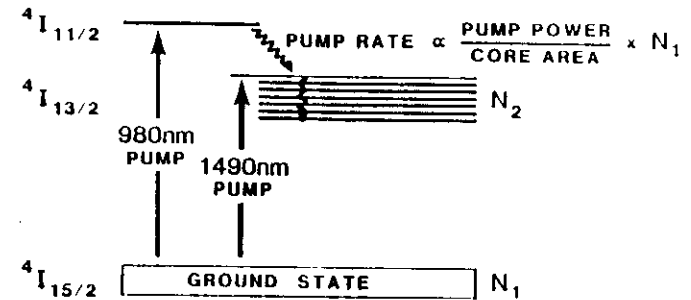
### Er<sup>3+</sup> - DOPED FIBRE ABSORPTION SPECTRUM SHOWING REGIONS OF EXCITED - STATE ABSORPTION



## ERBIUM-DOPED FIBRE AMPLIFIER BASICS



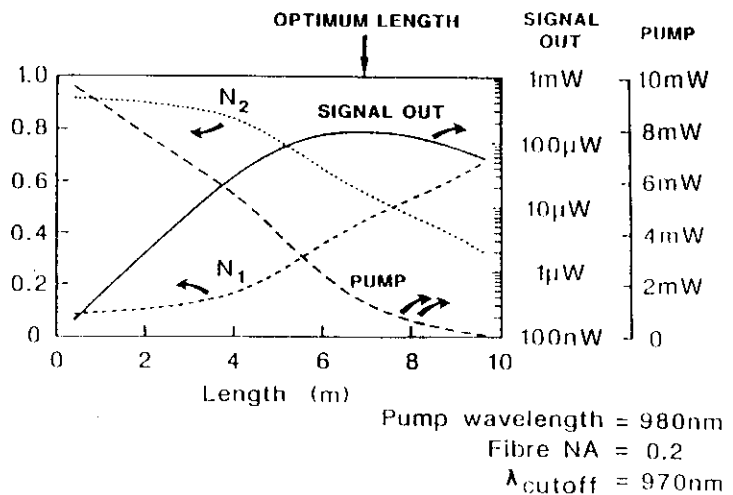
## ENERGY FLOW RATES IN ERBIUM-DOPED GLASS



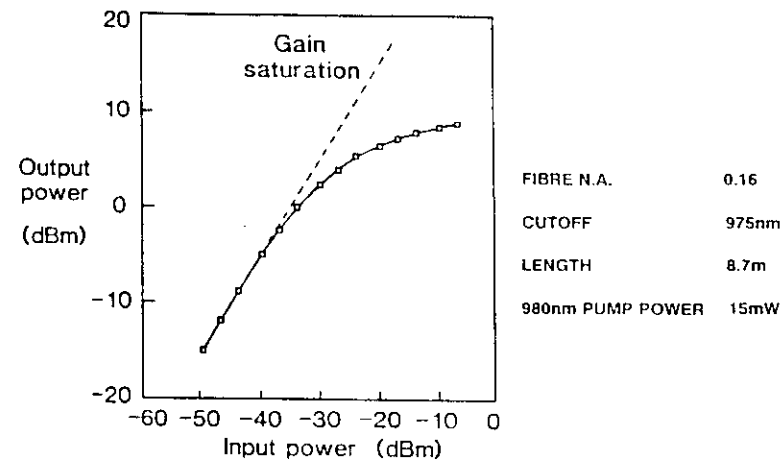
- o Pump-rate  $\propto$  Pump intensity  $\times N_1$
- o Low pump-rate due to
  - Long fluorescent decay time
  - Negligible non-radiative decay
- o Large energy stored wrt pump rate
- o Spontaneous emission  $\propto N_2/t_{sp}$
- o Amplified signal  $\propto$  Signal intensity  $\times (N_2 - N_1)$
- o Gain  $\propto (N_2 - N_1)$
- o Amplified spontaneous emission (ASE) power

$$= \mu \cdot h\nu \cdot \Delta\nu (G-1)$$

### VARIATION OF EDFA PARAMETERS WITH LENGTH

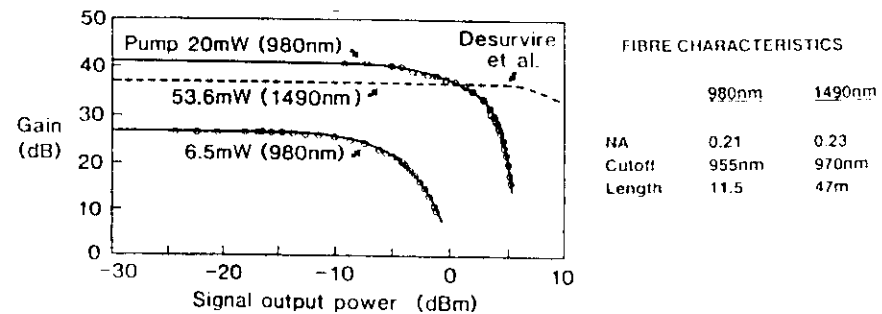


### AMPLIFIER INPUT / OUTPUT CHARACTERISTICS

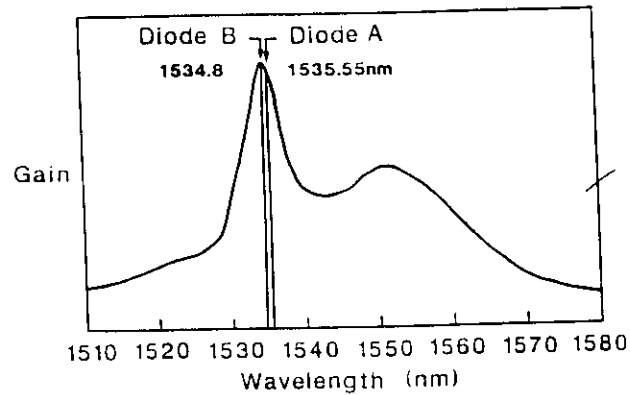


Pump quantum efficiency at 8.5dBm out is 44%

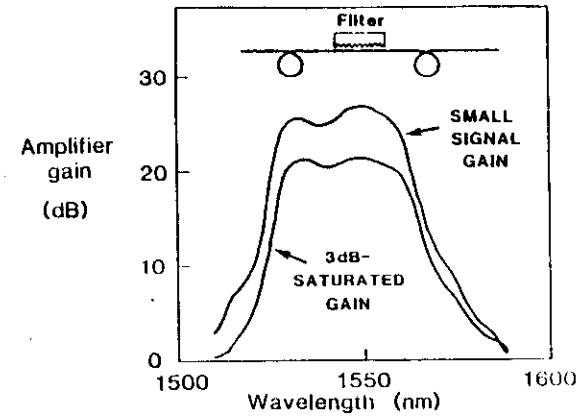
### ERBIUM FIBRE AMPLIFIER GAIN-SATURATION CHARACTERISTICS



TWO - WAVELENGTH INTERCHANNEL CROSSTALK MEASUREMENTS  
BOTH CHANNELS MODULATED



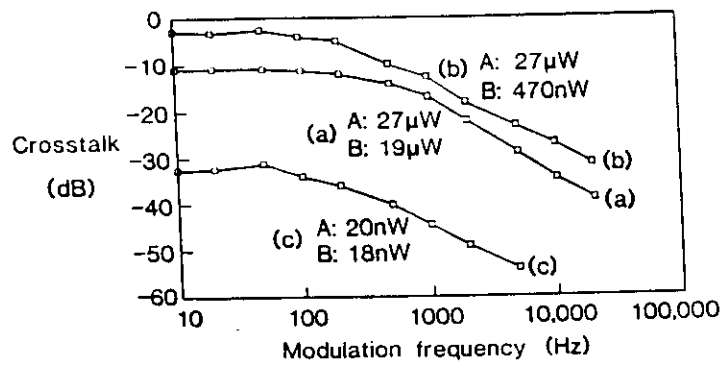
SPECTRAL GAIN-SHAPING IN AN EDFA



● Note constant spectral gain shape

DUAL WAVELENGTH CROSSTALK

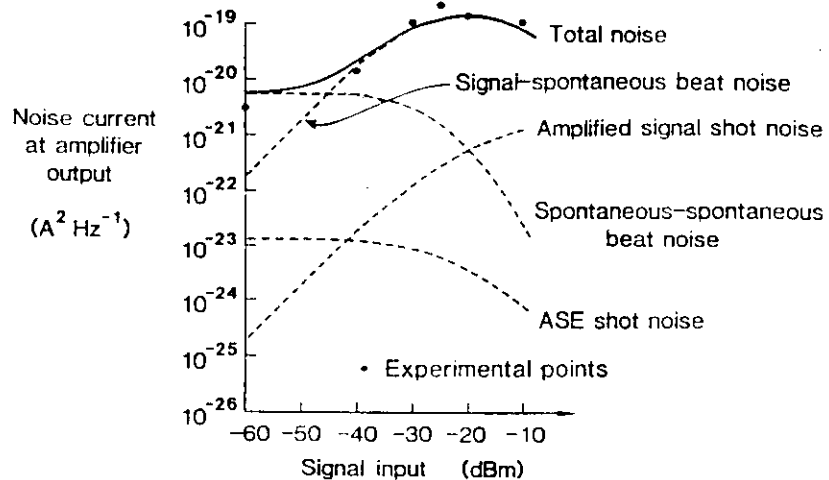
Diodes A & B at various input power levels



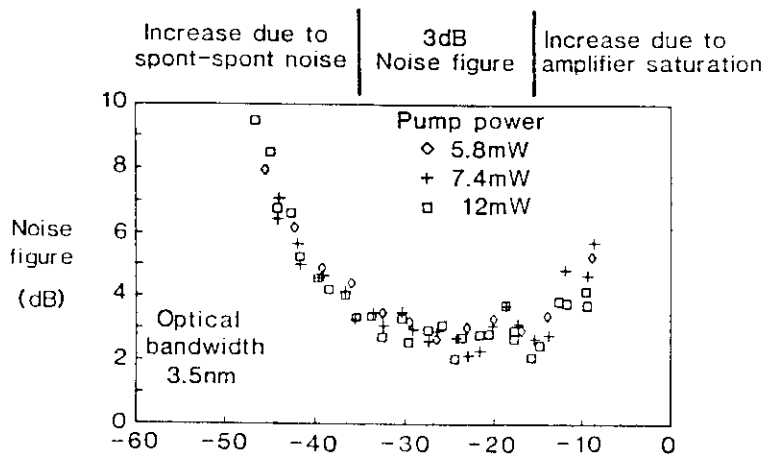
Crosstalk small above 10kHz



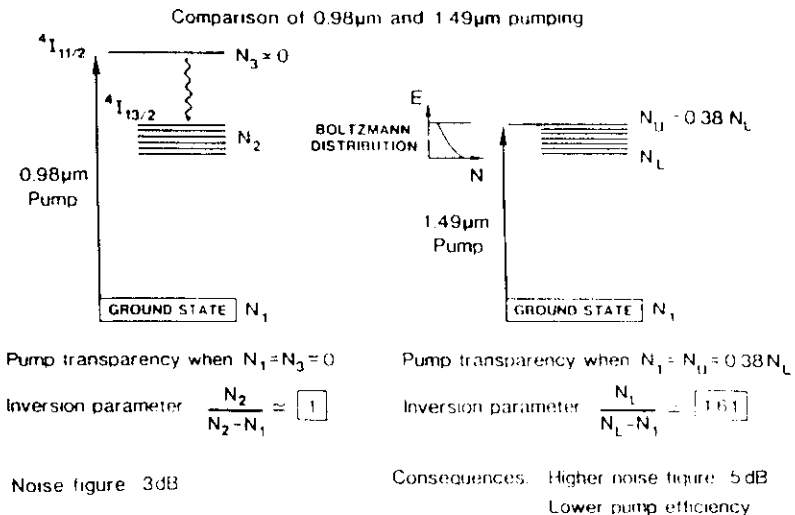
### NOISE PERFORMANCE OF AN Er<sup>3+</sup> FIBRE AMPLIFIER



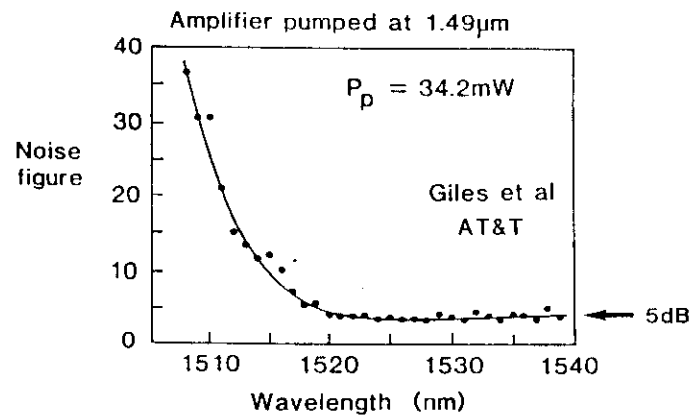
### MEASURED NOISE FIGURE FOR 980nm PUMPED AMPLIFIER



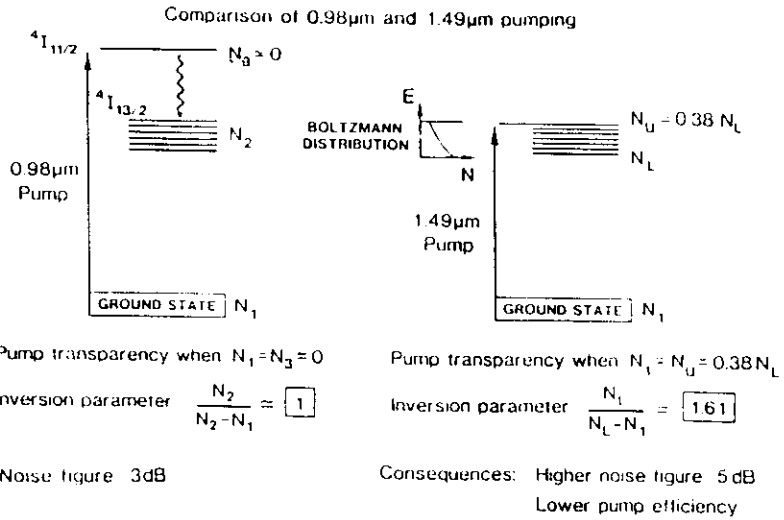
### ERBIUM FIBRE AMPLIFIER NOISE FIGURE



### NOISE FIGURE vs SIGNAL WAVELENGTH



### ERBIUM FIBRE AMPLIFIER NOISE FIGURE



### NOISE FIGURE vs SIGNAL WAVELENGTH

